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APPLICANTS

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** CONTINUING DATA *****

This application is a DIV of 09/858,964 05/17/2001 PAT 6,657,703 *P7*

** FOREIGN APPLICATIONS *****

JAPAN 148831/2000 05/19/2000 *P7*

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Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Examiner's Signature _____ Initials _____	STATE OR COUNTRY JAPAN	SHEETS DRAWING 15	TOTAL CLAIMS 12	INDEPENDENT CLAIMS 2
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TITLE

Exposure apparatus, maintenance method therefor, semiconductor device manufacturing method, and semiconductor manufacturing factory

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